



## **SCHIFF HARDIN LLP**

PATENT DEPARTMENT
6600 SEARS TOWER

233 SOUTH WACKER DRIVE

CHICAGO, ILLINOIS 60606

In re application of:

Mohammed A. Fathimulla et al.

H0002270-5866US01 (P02,0004-01) CONF. NO.: 9312

Serial No.:

10/764,938

**GROUP ART UNIT: 2814** 

JAW/AF

Filed:

January 26, 2004

EXAMINER: L. Pham

For:

SILICON-ON-INSULATOR WAFER FOR RF INTEGRATED CIRCUIT

## **RESPONSE TO 12/20/05 OFFICE ACTION**

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 SIR:

Transmitted herewith is an amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below.

	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONA FEE
TOTAL CLAIMS	*20	MINUS	*20*	0	( ) X 25.00 ( ) X 50.00	\$.00
INDEP. CLAIMS	* 3	MINUS	3	х	( ) X 100.00 ( ) X 200.00	\$.00
	mended to contain dependent claims paid for.			(') YES	()\$150.00 ()\$300.00 ONE TIME	\$.00

If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

**	If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20 write "20" in this space.
	Applicants petition the Commissioner of Patents and Trademarks to extend this time for response to the Office Action dated
	for month so that the period for response is extended to A check in the amount of \$ is attached to
	cover the cost of the extension. Any deficiency or overpayment should be charged or credited to deposit account No.
	501519. A duplicate copy of this sheet is enclosed.
	A check in the amount of \$ are attached.
	A check for \$ accompanying IDS under 37 CFR 1.97(c) is attached
	A check for \$ and Petition for Consideration of IDS under 37 CFR 1.97(d) is attached.
	The Commissioner is hereby authorized to charge any additional fees which may be required, or to credit any overpayment
	to account No. 501519. A duplicate of this sheet is enclosed.
	When phoning re this application, please call (312) 258-5774

SCHIFF HARDIN LLP (Customer Number: 000128)

BY All- akolomo (31,870

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on February 16, 2006.

Melvin A. Robinson

AME OF APPLICANT ATTORNEY

SIGNATURE
February 16, 2006

DATE

CH1\4237187.1

Applicants: M. A. Fathimulla, et al.

Serial No.: 10/764,938

FOY: SILICON-ON-INSULATOR WAFER FOR RF INTEGRATED CIRCUIT

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Confirmation No.: 9312

I hereby certify that this paper is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop AF, Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450 on this date:

February 16, 2006

Melvin A. Robinson Reg. No. 31,870

Attorney for Applicants

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Dear Sir:

## INTRODUCTION

Claims 1-6 and 22-35 remain in the application.

Claims 1-6 and 32-35 are rejected. Claims 22-31 are

directed to a non-elected invention.